

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Lu et al. Art Unit: 2826  
Serial No.: 10/722,013 Examiner: Erdem, F.  
Filing Date: 11/25/2003 Docket No.: TI-35669  
Customer No.: 23494 Conf. No.: 6979  
Title: A CAPACITOR FORMED ON A RECRYSTALLIZED POLYSILICON  
LAYER AND A METHOD OF MANUFACTURE THEREFOR

**REQUEST FOR EXTENSION OF TIME**

Commissioner of Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**CERTIFICATION OF FACSIMILE TRANSMISSION**

I hereby certify that the following papers are being transmitted by  
facsimile to the U.S. Patent and Trademark Office at 571-273-8300 on  
the date shown below:

  
Jacqueline J. Garner, Reg. No. 36,144

April 3, 2006  
Date

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner  
for an extension of the shortened statutory period for response in the above-identified  
Application.

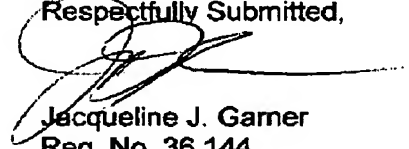
The fee for this extension is indicated below:

- ☒ One Month (\$120)  
☐ Two Months (\$450)  
☐ Three Months (\$1,020)  
☐ Four Months (\$1,590)

Please charge the fee to deposit account no. 20-0668. Any further necessary  
extension of time is hereby requested. Charge any and all fees to deposit account no. 20-  
0668.

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Respectfully Submitted,

  
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